Case No. 10519/29 Group Art Unit 2823 TRANSMITTAL LETTER Filing Date Example 19/918,853 July 30, 2001 F. To Inventor(s)

Vyvoda et al.

Title of Invention PROCESS FOR FABRICATING A DIELECTRIC FILM USING PLASMA OXIDATION Examiner F. Toledo

			TO THE CO	MMISSIONER FO	JK P	AILINIO				
	Transmitted here	ewith is <u>Tra</u>	nsmittal Letter (in du	uplicate); Respon	nse to	Election Re	quirement;	and Re	turn Postcard	•
	Small entity status of this application under 37 CFR § 1.27 has been established by verified statement previously submitted.									
	A verified statement to establish small entity status under 37 CFR §§ 1.9 and 1.27 is enclosed.									
	Petition for amonth extension of time.									
	No additional fe	e is required	i.							
	The fee has bee	en calculate	d as shown below:							
						Small	Entity		Other Small I	
	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra		Rate	Add'l Fee	or	Rate	Add'I Fee
Total		Minus				x \$9=		_	x \$18=	
Indep.		Minus				x 42=		4	x \$84=	
First Pre	esentation of Multi	ple Dep. Cla	aim			+\$140=		_	+ \$280=	
						Total add'l fee	\$		Total add'l fee	\$
	Please charge I copy of this she		count No. 23-1925 (ed.	BRINKS HOFER	R GIL	SON & LION	E) in the a	mount o	of \$ A	duplicate
	A check in the a	amount of \$	to cover the f	filing fee is enclos	sed.					
	The Commissioner is hereby authorized to charge payment of any additional filing fees required under 37 CFR § 1.16 and any patent application processing fees under 37 CFR § 1.17 associated with this communication or credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.									
\boxtimes	I hereby petitio Please charge copy of this she	any associa	CFR § 1.136(a) for ated fees which haved.	or any extension ve not otherwise	of the	ime required n paid to De	to ensure posit Acco	that thi unt No.	s paper is tim 23-1925. A	nely filed. duplicate
	Respectfully submitted,								TEC	
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				Joseph F. H Registration	etz		U		0 (PEC
				Attorney for	Appl	41,070 licant			- 6 -	
P.O. BO	S HOFER GILSON DX 10395 GO, ILLINOIS 606 21-4200			Attorney for	App	41,070 licant			CENTER 28	CEIVED
P.O. BO CHICAG (312) 32 I hereby of first class	OX 10395 GO, ILLINOIS 606 21-4200 certify that this correspon	10 Idence is being age, in an enve	deposited with the United lope addressed to: Comn	Attorney for	App	41,070 licant			GY CENTER 2800	EIVED

January Johnson Greby certify that this correspondence is being deposited with the Inited States Postal Service as first class mail with sufficient postage in an envelope addressed to: Commissioner for Patents, Washington, October 3, 2002 D.C. 20231 on _ Date of Deposit Joseph F. Hetz - Reg. No. 41,070 Name of Applicant, Assignee or Registered Representative Our Case No. 10519/29 Signature IN THE UNITED STATES PATENT AND TRADEMARK OFFICE In re Application of: Vyvoda et al. Examiner: F. Toledo 09/918,853/ Serial No.: 2823 Group Art Unit: July 30, 2001 Filed: Process for Fabricating a Dielectric For: Film Using Plasma Oxidation RESPONSE TO ELECTION REQUIREMENT Commissioner for Patents Washington, D.C. 20231 Dear Sir: In response to the election requirement mailed September 4, 2002, Applicants elect Species II, which is directed to Figure 5. Applicants submit that all claims are readable on Figure 5. Respectfully submitted, Dated: October 3, 2002 BRINKS HOFER GILSON & LIONE Joseph F. Hetz Reg. No. 41,070 P.O. Box 10395

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Attorney for Applicants